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** CONTINUING DATA *****

This application is a 371 of PCT/KR03/00786 04/17/2003

** FOREIGN APPLICATIONS *****

REPUBLIC OF KOREA 10-2002-0021554 04/19/2002

** SMALL ENTITY **

Foreign Priority claimed	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS DRAWING 4 ✓	TOTAL CLAIMS 13 ✓	INDEPENDENT CLAIMS 1 ✓
35 USC 119 (a-d) conditions met	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged Examiner's Signature		Initials			

ADDRESS

23413,

TITLE

Apparatus and method for depositing thin film on wafer using remote plasma

FILING FEE RECEIVED 555	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit
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